

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	: Hideto Ohnuma et al.	Art Unit	: 2812
Serial No.	: 09/925,512	Examiner	: Richard A. Booth
Filed	: August 10, 2001	Conf. No.	: 4989
Title	: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE		

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF AUGUST 8, 2006

Please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.